

參展廠商名錄資料刊登(線上)

免付費合展廠商線上刊登 (免費)

刊登資訊:

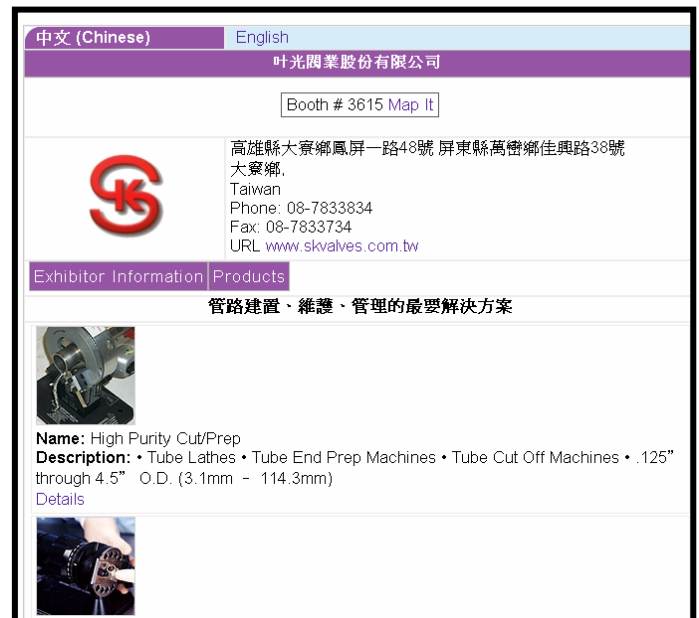
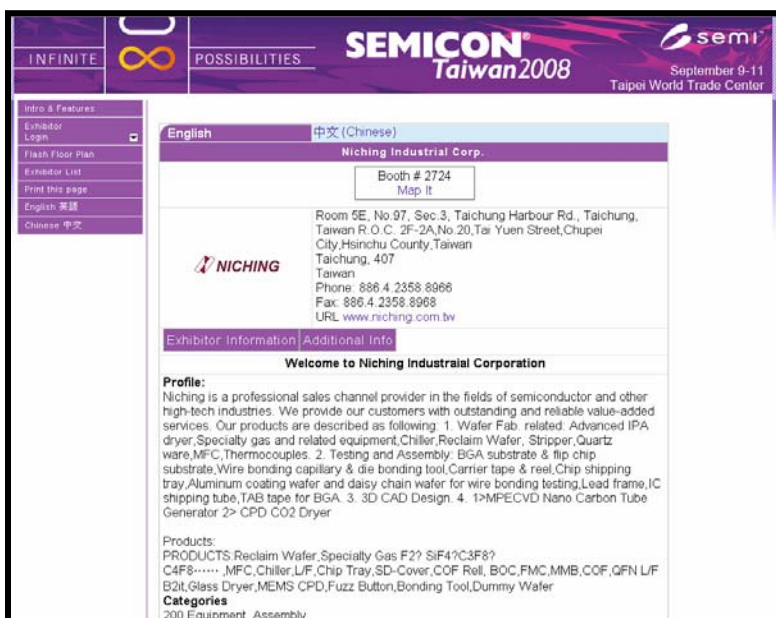
- 合展公司名稱
- 攤位編號
- 主要參展廠商公司名稱



付費合展廠商 / 主要廠商 線上刊登

線上刊登資訊:

- 公司名稱
- 攤位編號
- 聯絡資訊
- 公司簡介
- 產品類別
- 公司 Logo
- 產品訊息
- 產品詳細介紹
- 產品圖示



參展廠商名錄資料刊登 (書面)

免付費合展廠商資料刊登 (免費)

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- 攤位編號
- 主要參展廠商公司名稱



付費合展廠商 / 主要廠商 資料刊登

刊登資訊:

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- 攤位編號
- 聯絡資訊
- 公司簡介
- 產品類別



<p>RVSI INSPECTION LLC 425 Robro Drive East Hauppauge NY 11788 United States Tel: 1.631.273.9700 Fax: 1.631.273.1167 Email: info@rvsi.com Web: www.rvsi.com</p> <p>Exhibiting with Kronax International Corporation. RVSI Inspection is the world leader in inspection solutions for wafers as well as semiconductor packages. The WS800 Wafer system provides narrow defected inspection capability for wafers in both the front & back-ends. The WS800 offers optional 3-D inspection for variety of bump technologies. The WS has the best COO in the industry with the highest throughput, first pass yields & unprecedented reliability. The LS800 Pkg Sys offers capability to inspect variety of lead & lead-free packages. The AVS module on the LS800 provides capabilities to inspect visual defects on packages and passive components on BGA. Upgrade programs provide the most cost-effective way to improve production capacity.</p> <p>PRODUCTS: WS-3800 Wafer Inspection System, LS-8800 Package Inspector System</p>	HALL 1 - 486, 584	<p>Crystal Division * Flame Fused Quartz Ingots (Solid & Hollow), Discs & Plate * Flame Fused Tubes & Rods * Opaque Quartz Ingots, Discs, Rings & Plate * Electrical Fused Tubes & Rods * Spectrosil Synthetic Quartz Ingots, Tubes and Rods * Quartz Crucibles * Quartz Fused Quartz Wool, Felts and Textiles * Sapphire Tubes, Sheets and Welded components. Advanced Ceramics Division * Crystal SiC Boat, Tube, Liner, Injector & Pedestal... * Crystal SiC Paddle, Pi-Tube, Bowl & Bottle... * Crystal SiC Parts for Single Wafer Process * Crystal Plasma coating for Etch Chamber * Cerastat ESD Materials Grains & Powder SiC wire saw powder Performance Plastics ENG - Seal Products, Spring Energize Seal (Omni Seal) and Lip Seal, Polyimide Materials (Weldin 7000) for Plasma Clamp Ring, Wafer Test Probe Cards etc.</p> <p>亞克諾先進材料股份有限公司 104 台北市建國北路二段147號樓之11002室</p> <p>Sample of Paid Co-Exhibitors / 付費合展廠商刊登 Sample of Primary Exhibitors / 主要參展廠商刊登</p>
<p>SAMCO INC. 117-B Empire Commercial Bldg, 295 Kuang-Fu Rd., Sec. 2 Hsinchu 300 Taiwan Tel: 886.3.516.5100 Fax: 886.3.516.5101 Email: samco@ms72.hinet.net Web: www.samcointl.com</p> <p>SAMCO, Inc. is a process equipment company that develops and manufactures a wide variety of unique deposition, etching, and surface treatment systems for a worldwide network of major industrial customers and academic facilities. We provide process expertise and turnkey systems to major manufacturers in the compound semiconductor, optoelectronics, MEMS and other industries.</p> <p>PRODUCTS: Plasma CVD System for Depositing SiO₂ Thick Films; High-Volume Manufacturing Plasma CVD System; Plasma CVD System for Depositing SiN & SiO₂ Thin Films; High-Volume Manufacturing ICP Etching System; ICP Etching System for Compound Semiconductor Devices; ICP Etching System for Deep Si Etching; General Purpose Reactive Ion Etching System; General Purpose Plasma Cleaning System; UV/O₃ Dry Cleaner</p> <p>莎姆克株式會社 300 新竹市光復路二段295號帝國經貿大廈17樓8</p> <p>我們目前擁有從研發到大批量生產用的沉積設備、幹法刻蝕設備以及幹法清洗設備等在尖端半導體工藝上廣泛使用的設備。我們今後還將一直作為薄層技術的開發者，給世界上各公司和研究機構提供尖端技術和產品。</p>	HALL 1 - 846	<p>SAMCO INC. 117-B Empire Commercial Bldg, 295 Kuang-Fu Rd., Sec. 2 Hsinchu 300 Taiwan Tel: 886.3.516.5100 Fax: 886.3.516.5101 Email: samco@ms72.hinet.net Web: www.samcointl.com</p> <p>SAMCO, Inc. is a process equipment company that develops and manufactures a wide variety of unique deposition, etching, and surface treatment systems for a worldwide network of major industrial customers and academic facilities. We provide process expertise and turnkey systems to major manufacturers in the compound semiconductor, optoelectronics, MEMS and other industries.</p> <p>PRODUCTS: Plasma CVD System for Depositing SiO₂ Thick Films; High-Volume Manufacturing Plasma CVD System; Plasma CVD System for Depositing SiN & SiO₂ Thin Films; High-Volume Manufacturing ICP Etching System; ICP Etching System for Compound Semiconductor Devices; ICP Etching System for Deep Si Etching; General Purpose Reactive Ion Etching System; General Purpose Plasma Cleaning System; UV/O₃ Dry Cleaner</p> <p>莎姆克株式會社 300 新竹市光復路二段295號帝國經貿大廈17樓8</p> <p>我們目前擁有從研發到大批量生產用的沉積設備、幹法刻蝕設備以及幹法清洗設備等在尖端半導體工藝上廣泛使用的設備。我們今後還將一直作為薄層技術的開發者，給世界上各公司和研究機構提供尖端技術和產品。</p>
<p>S.E.S. CO., LTD. 1-4-13, Higashi Kuritachi-Sai Tokyo Daikoku-Kuritachi Building Kuritachi-City 186-0002 Japan Tel: 81.42.575.6800 Fax: 81.42.575.6801 Email: tara@ses-corp.co.jp Web: www.ses-corp.co.jp</p> <p>The improvement of wafer cleaning and drying technology has become more and more important along with the device miniaturization and the spread of 300mm wafers. To satisfy all kinds of customer's needs, S.E.S. Group is introducing the cleaning technology with the latest lineup of batch-type/single-type cleaning systems and dryers.</p> <p>PRODUCTS: Single Wafer Processing Wet Station "SS Series", Multi Bath Processing Wet Station "BWX Series", Dryer "MMD"; One Bath Processing Wet Station "DIGA WE1"</p>	HALL 1 - 2524	<p>SAFETY AND HEALTH TECHNOLOGY CENTER(SAHTC) R. 413, Bldg. 52, 195, Sec. 4, Chung-Hsing Rd., Chutung, Hsinchu 310, Taiwan Tel: 886.3.583.6885 Fax: 886.3.583.7538</p>
<p>SHINTO-GOBAIN ADVANCED MATERIALS TAIWAN CO., LTD. Suite 302, No.147, Chienkwo N. Road, Sec 2 Taipei 104 Taiwan Tel: 886.2.2503.4201 Fax: 886.2.2503.4202 Email: james.pan@shint-gobain.com Web: www.semiconductors.shint-gobain.com</p>	HALL 1 - 1272	<p>SAMSUNG Exhibiting with Ever Team International.</p> <p>HALL 1 - 1034</p> <p>SAMSUNG TECHWIN CO., LTD. Exhibiting with SELLING-WARE CO., LTD.</p> <p>Sample of Complimentary Co-exhibitors / 免付費合展廠商刊登</p>

125 EXHIBITORS